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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/832,660	04/11/2001	Eddie Daems	210484	1837
23460- 7.	590 03/11/2003			
LEYDIG VOIT & MAYER, LTD TWO PRUDENTIAL PLAZA, SUITE 4900 180 NORTH STETSON AVENUE			EXAMINER	
			SAGAR, KRIPA	
CHICAGO, IL 60601-6780			ART UNIT	PAPER NUMBER
			1756	
			DATE MAILED: 03/11/2003	<b>,</b>

Please find below and/or attached an Office communication concerning this application or proceeding.

	•	146					
	Application N .	Applicant(s)					
· · · · · · · · · · · · · · · · · · ·	09/832,660	DAEMS ET AL.					
Office Action Summary	Examiner	Art Unit					
	Kripa Sagar	1756					
The MAILING DATE of this commun Period for Reply	ication appears on the cover sh	eet with the correspondence address					
A SHORTENED STATUTORY PERIOD F THE MAILING DATE OF THIS COMMUN  - Extensions of time may be available under the provisions after SIX (6) MONTHS from the mailing date of this comr  - If the period for reply specified above, the maximum st  - Failure to reply within the set or extended period for reply  - Any reply received by the Office later than three months a earned patent term adjustment. See 37 CFR 1.704(b).  Status	ICATION. s of 37 CFR 1.136(a). In no event, however, nunication. sto) days, a reply within the statutory minimur atutory period will apply and will expire SIX (a) will, by statute, cause the application to bec	may a reply be timely filed  n of thirty (30) days will be considered timely.  6) MONTHS from the mailing date of this communication.  come ABANDONED (35 U.S.C. § 133).					
1) Responsive to communication(s) fi	led on <u>30 December 2002</u> .						
2a) ☐ This action is <b>FINAL</b> .	2b)⊠ This action is non-final.						
		al matters, prosecution as to the merits is					
closed in accordance with the practice Disposition of Claims	lice under Ex parte Quayle, 19	33 C.D. 11, 453 O.G. 213.					
4)⊠ Claim(s) <u>20-38</u> is/are pending in the application.							
4a) Of the above claim(s) is/a	4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.	Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>20-38</u> is/are rejected.	aim(s) <u>20-38</u> is/are rejected.						
7) Claim(s) is/are objected to.	s) is/are objected to.						
8) Claim(s) are subject to restrict	ction and/or election requireme	nt.					
Application Papers	۰ .						
9) The specification is objected to by the		the table to the European					
10)⊠ The drawing(s) filed on <u>01 April 2001</u>							
Applicant may not request that any ob  11) The proposed drawing correction file		• • • • • • • • • • • • • • • • • • • •					
If approved, corrected drawings are re							
12) The oath or declaration is objected to	•	•					
Priority under 35 U.S.C. §§ 119 and 120	•						
13)⊠ Acknowledgment is made of a claim	n for foreign priority under 35 U	.S.C. § 119(a)-(d) or (f).					
a)⊠ All b)☐ Some * c)☐ None of:							
1.⊠ Certified copies of the priority documents have been received.							
	2. Certified copies of the priority documents have been received in Application No						
	national Bureau (PCT Rule 17.2						
14)⊠ Acknowledgment is made of a claim	for domestic priority under 35 U	J.S.C. § 119(e) (to a provisional application).					
a) ☐ The translation of the foreign la 15)☐ Acknowledgment is made of a claim							
Attachment(s)							
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (I 3) Information Disclosure Statement(s) (PTO-1449) F	PTO-948) 5) No	erview Summary (PTO-413) Paper No(s) tice of Informal Patent Application (PTO-152) her:					

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#### **DETAILED ACTION**

## Response to Amendment

- 1. The amendment filed on 12/30/02 has been entered.
- 2. Since only punctuation errors have been corrected, no new matter has been added. Claims 20-38 are under consideration.
- 3. In view of the amendment and arguments all rejections presented in the last office action are withdrawn.

## Claim Rejections - 35 USC § 112

4. Claim 20 is rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

The claim recites a limitation "wherein steps (a) to (d) are performed within a period of less than two months". It is not clear if the claim refers to extensive rest periods between *any two* steps in the sequence (a) through (d). Though the specification refers to this period, it does not provide any clarification to the limitation. For the purposes of examination it is assumed that the shelf life refers to storage after lamination conventionally known in the art.

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# Claim Rejections - 35 USC § 103

4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

5. Claims 20,21, 27-33,35-37 are rejected under 35 U.S.C. 103(a) as being unpatentable over US Pat. 5262275 to Fan in view of US Pat. 6143470 to Nguyen et al.

The instant claims disclose a method of forming a relief image using an imaging element on a UV-sensitive relief-forming layer. The imaging element, with a peelable layer, is imaged. The element is used as a conformable mask to expose the UV - sensitive layer and developing it to form the relief image.

Fan discloses a flexographic printing element comprising a barrier layer and an infrared (IR) sensitive imaging layer on a photo-polymerizable layer. Fan teaches laminating the barrier layer and the IR-sensitive layer on the photo-polymerizable layer. The IR-sensitive layer is image-wise exposed by laser ablation. The photo-polymerizable layer is flood exposed using the layers above as mask. The overlying layers and the non-imaged areas are developed and removed. (2;34-45). A temporary coversheet on the photo-polymerizable layer (if present) is removed prior to lamination(8;27-40). A peelable top layer is optionally included. This top layer on the IR

sensitive layer may remain on the laminated composite for storage but is removed prior to imaging by laser ablation. Fan teaches composition of IR sensitive layers (claims 22-23) and includes metals(5; 56-7-45). The top peelable layer( claims 27,32) is a silicone coated mylar layer (15;9-10). A separate development step for removing the IR-sensitive layer and the barrier layer is disclosed (10;51-56). The UV-sensitive material (claims 33,35) may be a photoresist ("photocrosslinkable") or a flexographic ("photopolymerizable") precursor (3;1-10). Fan specifies a barrier layer which is adhered to the UV-sensitive layer by pressure or heat or both. It teaches a peelable protective sheet over the barrier layer (7;66-8;10). Fan teaches that the laminated element may be stored (7;48-50).

Fan provides for a laminated imaging material and does not teach a distinct adhesive layer between the image receiving layer and the UV-sensitive layer.

Nguyen (Fig.3) teaches that an adhesive material (303) would be required when laminating an image-receiving layer (305) to a photosensitive layer (302).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to use an adhesive layer between the image receiving layer and the photosensitive layer as taught by Nguyen in Fan's lay-up because Nguyen teaches that the adhesive layer facilitates peeling after processing (8;66-67 & Fig.3).

6. Claims 20 is rejected under 35 U.S.C. 103(a) as being unpatentable over Nguyen in view of Fan.

Nguyen teaches laminating an image receiving layer and an adhesive layer onto a UV-sensitive layer on a support. The imaging layer is image exposed to ablative laser writing, and the stack is flood exposed and developed (Fig.3).

Nguyen does not teach a peelable top support or storage for two months.

Fan teaches a peelable top support and states that the laminate can be stored with the support (8;51-60).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Nguyen's stack with Fan's peelable support layer because Fan teaches that it protects the imaging layer from scratches during handling and storage (8;51-60).

7. Claims 22-26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Fan in view of Nguyen as applied to claim 20 above in view of US Pat.5888712 to Lelental et al.

The instant claims recite the limitations on the imaging layer in the mask.

The teachings of Fan and Nguyen have been discusses above. Fan and Nguyen teach the composition of the imaging layer; however these are directed towards a laser-ablatable process. They do not specify other imaging methods or elements.

Lelental's invention is directed towards forming a conductive layer over imaging layers used in fabricating printing plates. It teaches conventional image forming layers and methods. Such imaging elements include, for example, photographic, thermographic, electrothermographic, photothermographic, dielectric recording, dye migration, laser dye-ablation, thermal dye transfer, electrostatographic, and

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electrophotographic imaging elements (12;34-48).

It would have been obvious to one of ordinary skill in the art at the time the invention was made to combine the teachings of Lelental to include diverse imaging elements in the mask-forming layer taught by Fan with Nguyen's adhesive layer, because Fan teaches the advantages of integrating the mask ("phototool") with the relief-forming layer (1;49-65) and Nguyen teaches a practical method of integration while Lelental teaches numerous image forming elements conventionally available for use in the integrated mask.

8. Claims 34, 38 are rejected under 35 U.S.C. 103(a) as being unpatentable over Fan in view of Nguyen as applied to claim 20 above in view of US Pat.4555471 to Barzynski et al.

The claim recites the limitations on the UV sensitive material and peeling off the mask layer as a development step.

The teachings of Fan have been discussed above. It teaches the precursors for a flexographic printing plate. It does not teach the relief layer for a lithographic plate. It teaches laser ablation to image the mask layer (IR-sensitive layer) and provides for development steps to remove the mask layer. It does not teach peeling the mask layer. Nguyen teaches peeling the image forming stack after exposure. It does not teach a flexographic printing plate.

Barzynski's invention is directed towards a multilayer image recording material used in printing plates. It teaches prior art structures for lithographic printing plates (1; 20-26). It teaches the use of thermographic materials in the imaging layer of the mask.

The mask layers and the relief imaging layers are formed separately and laminated. Following the imaging process, the mask layers may be peeled off (7;54-64).

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It would have been obvious to one of ordinary skill in the art at the time the invention was made to combine the teachings of Barzynski Nguyen and Fan. Fan teaches the advantages of integrating the mask ("phototool") with the relief-forming layer (1;49-65), Nguyen teaches a practical method of integration, while Barzynski teaches that this can be accomplished with a peelable mask that dispenses with the wet processing steps (generally associated with other masks), thereby assuring good quality images during processing (8;57-65).

## Response to Arguments

9. Applicant's arguments with respect to claims 20 - 38 have been considered but are not relevant in view of the new ground(s) of rejection.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kripa Sagar whose telephone number is 703-605-4427. The examiner can normally be reached on 8:00AM--5:00PM (M-F).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark F Huff can be reached on 703-308-2464. The fax phone numbers for

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the organization where this application or proceeding is assigned are 703-872-9310 for regular communications and 703-872-9311 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-

0661.

MH/ks February 25, 2003 MARK F. HUFF SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 1700 Page 8